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December 15, 1999

To: Examiner M. Budd 703-305-1341From: Thu A. DangYour Ref.: 09/142,464Our Ref.: JAO 40853Number of Pages Sent (Including cover sheet): 10Prepared By: TAD**COMMENTS:**

Further to our 12/14 telephone conference, enclosed are copies of the Preliminary Amendment filed on 9/8/98 and the stamped postcard receipt. Please contact us with you have any questions or comments.

D _____ M _____

Sent by: _____

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PTO RECEIPT FOR FILING OF PAPER

The following papers have been filed:

U.S. National Stage Appln. Trans., #10044, (\$1,144); PCT Request; 41 pp. spec/claims (26)/abstr., 8 shts. of drws., (Figs. 1A-13B); Request for Appr. of Draw. Correc.; Prelim. Amdt.; IDS, PTO 1449 w/9 refs. (+Srch. Rpt.).

Name of Applicant:	Yasumitsu IKEGAMI
Serial No.:	U.S. National Stage of PCT/JP97/04623 filed December 16, 1997
Atty. File No.:	JAO 40853
Title (New Cases):	PIEZOELECTRIC RESONATOR, METHOD FOR MANUFACTURING SAME AND PIEZOELECTRIC RESONATOR UNIT
Sender's Initials:	JAO:TAD/kmg 09/142464

404 Rec'd PCT/PTO 08 SEP 1998
280,24

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasumitsu IKEGAMI

Application No.: U.S. National Stage of PCT/JP97/04623

Filed: September 8, 1998

Docket No.: JAO 40853

For: PIEZOELECTRIC RESONATOR, METHOD FOR MANUFACTURING SAME AND
PIEZOELECTRIC RESONATOR UNITPRELIMINARY AMENDMENTAssistant Commissioner of Patents
Washington, D. C. 20231

Sir:

Prior to initial examination, please amend the above-identified application as follows:

IN THE SPECIFICATION:

Page 1, line 1, delete "SPECIFICATION";

line 4, change "Field of the Invention" to --Background of the
Invention--;between lines 4 and 5, insert --1. Field of Invention--; andline 9, change "Background of the Invention" to --2. Description of
Related Art--.Page 6, between lines 23 and 24, insert --SUMMARY OF THE INVENTION--.

Page 7, line 14, delete "Disclosure of the Invention".

Page 17, line 15, change "Best Modes for Carrying Out the Invention" to
--DETAILED DESCRIPTION OF PREFERRED EMBODIMENTS--.